

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
TAKASHI ARAI) : Examiner: F. Lawrence
Application No.: 10/634,860) : Group Art Unit: 1724
Filed: August 6, 2003) : Confirmation No. 8192
For: METHOD OF STORING) :
MATERIAL INTO WHICH GAS :
SATURATES) September 13, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Mail Stop Issue Fee

AMENDMENT UNDER 37 C.F.R. § 1.312

Sir:

A. Introductory Comments

Prior to the payment of the issue fee, please amend the above-captioned application as follows.